

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Haerle et al. Art Unit : 2879
Serial No. : 10/670,917 Examiner : German Colon
Filed : September 24, 2003 Conf. No. : 6535
Title : DISPLAY DEVICE AND METHOD OF ITS MANUFACTURE

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, the communication being dated December 8, 2006, which is not more than three months prior to the filing of this statement. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: _____

January 22, 2007

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Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12406-055001	Application No. 10/670,917
	Applicant Haerle et al.		
	Filing Date September 24, 2003	Group Art Unit 2879	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	EP 1 134 811 A1	09/2001	EP				
	AM	EP 1 450 587	08/2004	EP				
	AN	JP 06-067187	03/1994	JP			English Abstract	
	AO	WO 97/06554 A2	02/1997	WIPO				

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AP	R. L. Hoffmann et al., "ZnO-based Transparent Thin-Film Transistor", February 3, 2003, Applied Physics Letters, Vol. 82, No. 5, pp. 733-735.
	AQ	
	AR	
	AS	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	